IFN

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN THE Patent Application of:

Serial No. 10/717,370

Confirmation No. 6723

Filing Date: November 19, 2003 Art Unit: 1765

For: METHOD FOR MAKING
SEMICONDUCTOR DEVICE
INCLUDING BAND-ENGINEERED
SUPERLATTICE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

A SEMICONDUCTOR OF STATES PATENT

PRELIMINARY AMENDMENT

Mail Stop Amendment Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Sir:

Prior to the calculation of fees and examination of the present application, please enter the amendments and remarks set out below.

1